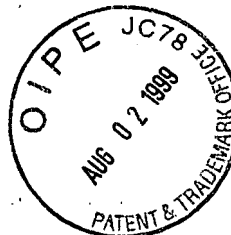


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Schultz, et al.
Serial No.: 09/305,017
Filed: May 4, 1999
For: Illumination System Particularly
for EUV Lithography
Art Unit: 2872
Examiner: Not Yet Assigned



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Attorney Docket: 637.0001USU

Date: July 29, 1999

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

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In accordance with applicants' duty of disclosure under 37 C.F.R. §1.56, we are enclosing form PTO-1449 listing information that may be material to the patentability of this application, filed May 4, 1999.

We are enclosing a copy of the following article, which is listed on form PTO-1449.

"Handbook on Synchrotron Radiation" Ernst-Eckhard Koch ed., pp. 140-145, 1098-1111 (1983).

It should be understood that attention has been called to the publications that have been deemed to be pertinent to the

claimed present invention. In concluding what was pertinent, the criteria employed was considered most appropriate in light of the invention shown in the present publication. However, the Examiner or others may deem some other criteria to be just as appropriate or more appropriate. Therefore, the Examiner is respectfully urged to review the listed publication and to make the usual careful independent search for other prior art that may be pertinent.

Since this Supplemental Information Disclosure Statement is being submitted prior to the first Office Action on the merits, no petition or fee is required.

Applicants respectfully request favorable consideration and that this application be passed to allowance.

Respectfully submitted,



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